

PATENT

Attorney Docket No.: SAM-0298

IN THE UNITED STATES PATENT AND TRADEMARK OFFICEApplicant(s): Jae-Hak Kim, *et al.*

Serial No.: 09/994,508

Filing Date: November 27, 2001

Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICES HAVING LOW
DIELECTRIC INTERLAYER INSULATION LAYER

Examiner: Steven H. Rao

Group Art Unit: 2814

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper and any attachments hereto are being forwarded to the United States Patent and Trademark Office via facsimile at the facsimile telephone number and on the date indicated below.

3/11/05

Date

(571) 273-1718

Facsimile Number



Chelsey Davis

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

The following amendment is submitted in accordance with the telephone interviews conducted with the undersigned on March 3, 2005 and March 10, 2005. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

PATENT
Attorney Docket No.: SAM-0298
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-Hak Kim, *et al.*
Serial No.: 09/994,508
Filing Date: November 27, 2001
Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICES HAVING LOW
DIELECTRIC INTERLAYER INSULATION LAYER


Examiner: Steven H. Rao
Group Art Unit: 2814

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper and any attachments hereto are being forwarded to the United States Patent and Trademark Office via facsimile at the facsimile telephone number and on the date indicated below.

3/11/05
Date

(571) 273-1718
Facsimile Number


Chelsey Davis

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER

Sir:


Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Supplemental Amendment

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: 3/11/05
Mills & Onello LLP
Eleven Beacon Street, Suite 605
Boston, MA 02108
Telephone: (617) 994-4900
Facsimile: (617) 742-7774
J:\SAM\0298\SuppAmend\transuppamend.wpd


Steven M. Mills
Registration Number 36,610
Attorney for Applicant

MILLS & ONELLO LLP

ATTORNEYS AT LAW
PATENTS TRADEMARKS AND COPYRIGHTS

ELEVEN BEACON STREET, SUITE 605
BOSTON, MASSACHUSETTS 02108

TELEPHONE: (617) 894-4900
FACSIMILE: (617) 742-7774
E-MAIL: MAIL@MILLSONELLO.COM

Handwritten signature: P. Mills
Handwritten initials: sk
Handwritten date: 03/11/05

FACSIMILE TRANSMISSION

TO: United States Patent and Trademark Office **FROM:** Steven M. Mills
Examiner Steven H. Rao
Group Art Unit: 2814

FAX NO: (571) 273-1718

DATE: March 11, 2005

RE: U.S. Patent Application
"Method of Fabricating Semiconductor Devices Having Low Dielectric
Interlayer Insulation Layer," by Jae-Hak Kim, *et al.*
U.S. Serial No.: 09/994,508
U.S. Filing Date: November 27, 2001
Attorney Docket Number: SAM-0298

NUMBER OF PAGES INCLUDING COVER SHEET: 10

REMARKS:

The documents transmitted by this facsimile are intended for the use of the individual or the entity to which it is addressed and may contain information that is privileged, confidential, and exempt from disclosure under applicable law. If the reader of the message is not the intended recipient, or the employee or agent responsible for delivering this document to the intended recipient, you are hereby notified that any dissemination, distribution, or copying of this communication is strictly prohibited. If you have received this communication in error, please notify us immediately by telephone and return the original facsimile to us at the above address via the Postal Service. Thank you.

J:\SAM\0298\SuppAmend\USPTO-fax.wpd